

03560.002732.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: K. Fernandez
Masato MURAKI et al.)	
	:	Group Art Unit: 2881
Application No.: 09/708,590)	
	:	Allowed: June 4, 2003
Filed: November 9, 2000)	
	:	Confirmation No.: 2106
For: CORRECTING METHOD FOR)	
CORRECTING EXPOSURE DATA USED :	:	September 3, 2003
FOR A CHARGED PARTICLE BEAM)	
EXPOSURE SYSTEM	:	

Mail Stop RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED FORMAL DRAWING

Sir:

Transmitted herewith is one (1) sheet of a formal drawing, Figure 5, to be substituted for the corresponding drawing sheet currently on file in the above-identified application.

This formal drawing incorporates the changes requested by Applicants in a Request for Approval of Drawing Changes filed on January 28, 2003, which were subsequently approved by the Examiner in the Notice of Allowability dated June 4, 2003.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Steven E. Warner", is written over a horizontal line.

Attorney for Applicants

Steven E. Warner

Registration No. 33,326

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